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IPW

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Inventors: Fusao Ishii and Fumitomo Hide

Docket No.: Fishii004

Application No.: 10/763,672

Examiner: Tra, Tuyen Q.

Filed: January 24, 2004

Group: 2873

Title: Micromirrors with support walls

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Signed:



Fumitomo Hide

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Mail Stop Amendment
Honorable Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

AMENDMENT A

Dear Examiners:

In response to the Office Action dated June 1, 2005, please amend the above identified patent application as follows:

In the Claims:

Please amend claims 1, 8, 9, 10, 14, 19, and 28 as follows:

1. (Amended) A micromirror device comprising:
a reflecting element that can be deflected into at least 2 states; and
a support structure other than a post for supporting said reflecting element, said support structure comprising at least 1 wall, wherein said support structure is sufficient to support said reflecting element and said support structure is in direct contact with said reflecting element.

8. (Amended) The device of claim [1] 7, wherein said angle is between 0° and 60°.

9. (Amended) The device of claim [1] 7, wherein said angle is between 0° and 45°.